



Bundesministerium für Bildung und Forschung



Thermal transmittance measurements of SIS & Nb₃Sn coated samples at cryogenic temperatures

19.09.2024

Marc Wenskat – on behalf SRF R&D Team emphasis on Leon King, Anton Lorf, Cem Saribal

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- To achieve gradients >50 MV/m we need to study thermal transmittance $\mathbf{K} = \left(\frac{d}{\lambda} + R_K\right)^{-1}$
- Does overall thermal transmittance *K* deteriorate after coating of Nb?
 - Is the thermal conductivity λ the culprit?
 - The thermal interface resistance R_{th} between layer and substrate?
 - What about the Kapitza-Resistance R_{κ} of the coated layer?







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We know A, control \dot{Q} and measure T_i and T_o

$$\underbrace{\left(\frac{d}{\lambda} + R_{K}\right)}_{\gamma}\dot{Q} = A \cdot (T_{i} - T_{o})$$

 $1/K \rightarrow$ This is what we obtain

Т

Measurement procedure





Measurement procedure



Measurement procedure





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Cell Ø=106mm Sample Ø=45mm





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T-sensor inside & outside Manganin heating wire inside



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T-sensor inside & outside Manganin heating wire inside



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Parasitically installed at cavity insert





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Parasitically installed at cavity insert



- Filling by 1m capillary with Ø=1mm to thermally decouple inside
- Electrical wires go through there (heater & T-sensor)
- Only glued / screwed \rightarrow high chance of leaks



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$$K(\dot{Q}) = K_0 + a \cdot \left(\frac{\dot{Q}}{\dot{Q}_0}\right)^n$$



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- 1 pair was coated **both sides** with
 - 15nm/60nm AIN/NbTiN via PEALD (as-deposited)
 - +1h@900°C to achieve high $T_c^{[1]}$ (annealed)

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All measurements shown are at 2K

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 - $K_0 = (150 200) \text{ mW cm}^{-2} \text{ K}^{-1}$
- Measured as-fabricated (only water-jet cutting)
 - $K_0 = (307 \pm 46) \text{ mW cm}^{-2} \text{ K}^{-1}$
 - $K_0 = (332 \pm 31) \text{ mW cm}^{-2} \text{ K}^{-1}$
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Can we trust the results? Yes, they are reasonable

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SIS does not reduce the thermal transmittance K

- As-deposited $K_0 = (141 \pm 13) \text{ mW cm}^{-2} \text{ K}^{-1}$
- After annealing $K_0 = (156 \pm 10) \text{ mW cm}^{-2} \text{ K}^{-1}$
- SIS on both sides \rightarrow many interfaces

Well within the baseline Nb value!

 Nb_3Sn shows increased K_0 after coating one side

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- Next steps:
 - Coat second sample pair, measure K₀
 - Measure roughness before & after
 - Compare to as-fabricated roughness
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- Next-gen cell with soldered stainless steel capillary is currently fabricated

Thanks to...

- you for listening
- the **conveners** for the opportunity to present this work
- **DESY** for the measurement opportunities
- **BMBF** for funding

Questions?

Swartzwelder, J. (Writer), & Reardon, J. (Director). (1994, January 6). Homer the Vigilante (Season 5, Episode 11) [TV series episode]. In D. Mirkin, J. L. Brooks, M. Groening, & S. Simon (Executive Producers), *The Simpsons*. Gracie Films; Twentieth Century Fox Film Corporation.

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Temperature Scan

- Started testing temperature scans while cooling down at QvT
- High power to be close to K₀
- Measurement starts at 2.1K

